Materials for HEP Detectors

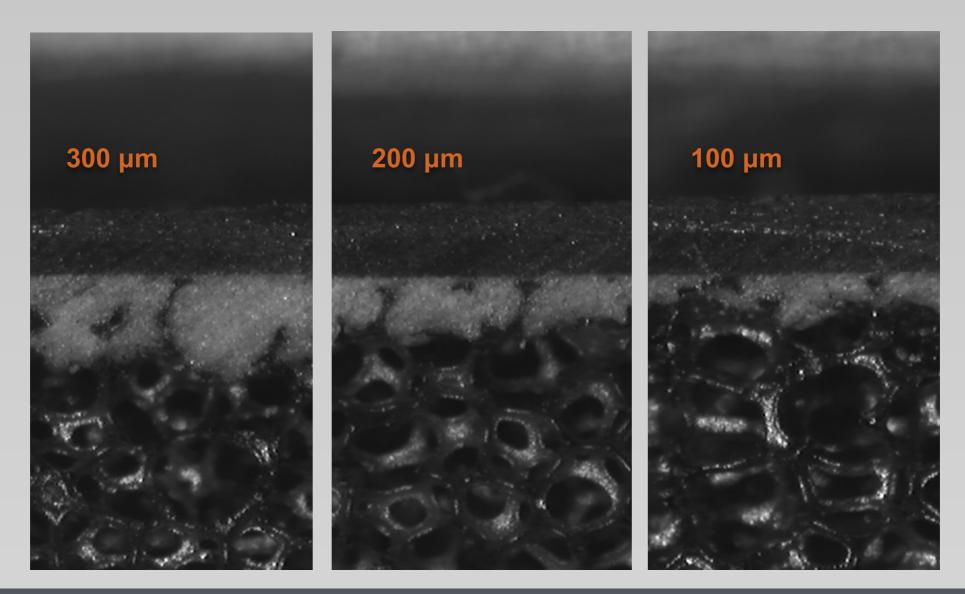
D. Ariza, K. Beernaert, S. Diez Cornell, N. Flaschel, V. Fracassi, K. Gadow, D. Grunwald, P. Gunnelini, K. Hansen, J. Keaveney, G. Mittag, <u>A. Mussgiller</u>, C. Niebuhr, E. Ntomari, V. Prahl, O. Reichelt, E. Rosenthal, R. Stever, P. Vidal, H. Ye 09/03/2016





CVD Carbon Foam

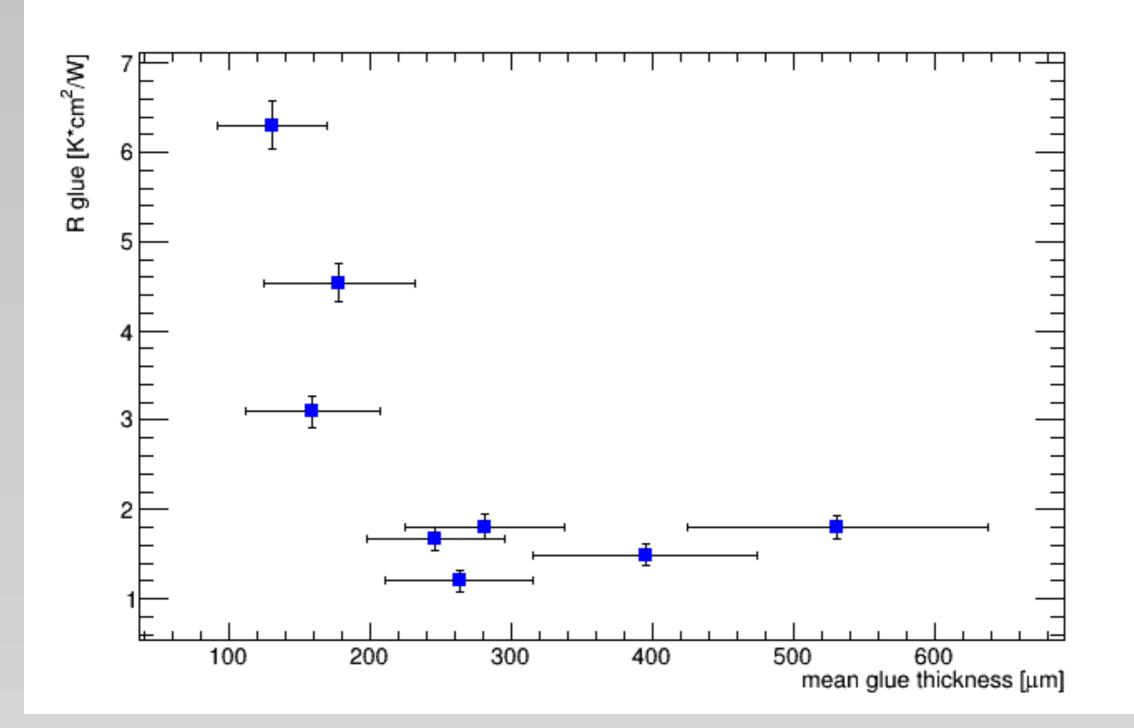
- high thermal conductivity at low density
 - thermal conductivity: 10 W/m/K 75 W/m/K
 - density: 0.09 g/cm³ 0.35 g/cm³
- thermal impedance of contact between foam and pipe / CFRP / ... depends in amount of glue
 - glue is mostly pushed into the foam and increases contact area
 - not enough glue: large thermal impedance
 - too much glue: excess mass



CVD Carbon Foam - Measurements

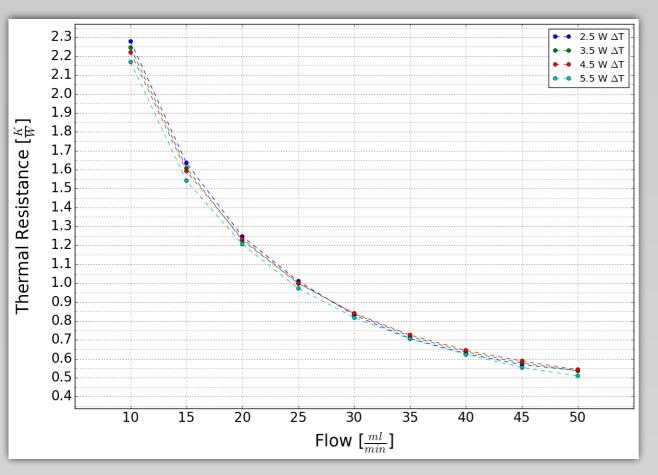
CMS

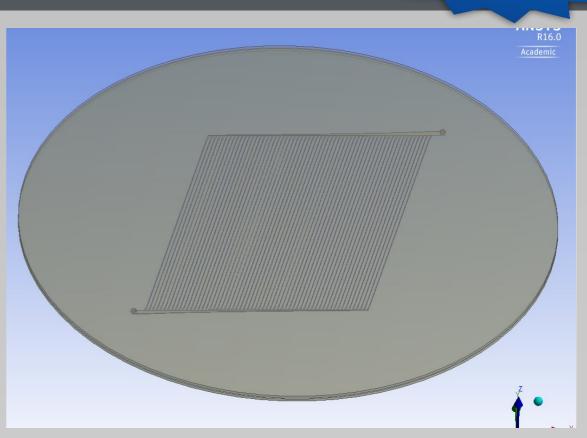
- thermal impedance as a function of glue thickness was investigated
 - thermal impedance reaches a minimum at about a glue thickness of 250 μm



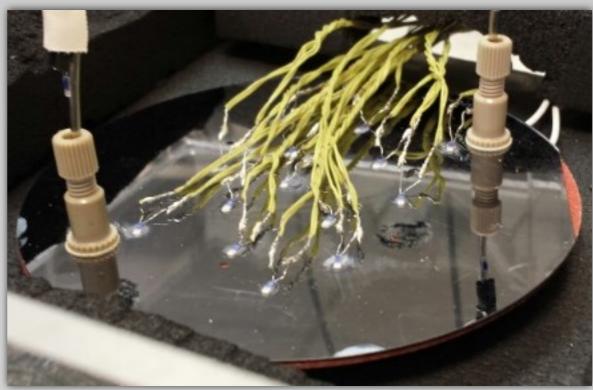
Microchannel Cooling

- microchannels etched into 4" silicon wafer of 500 µm thickness
- sixty 100 µm x 100 µm channels connected via manifolds
 - 675 µm pitch
- integrated into setup containing flow, pressure and temperature sensors
- wafer equipped with 4" heater
- temperature sensors on the surface and at the inlet and outlet



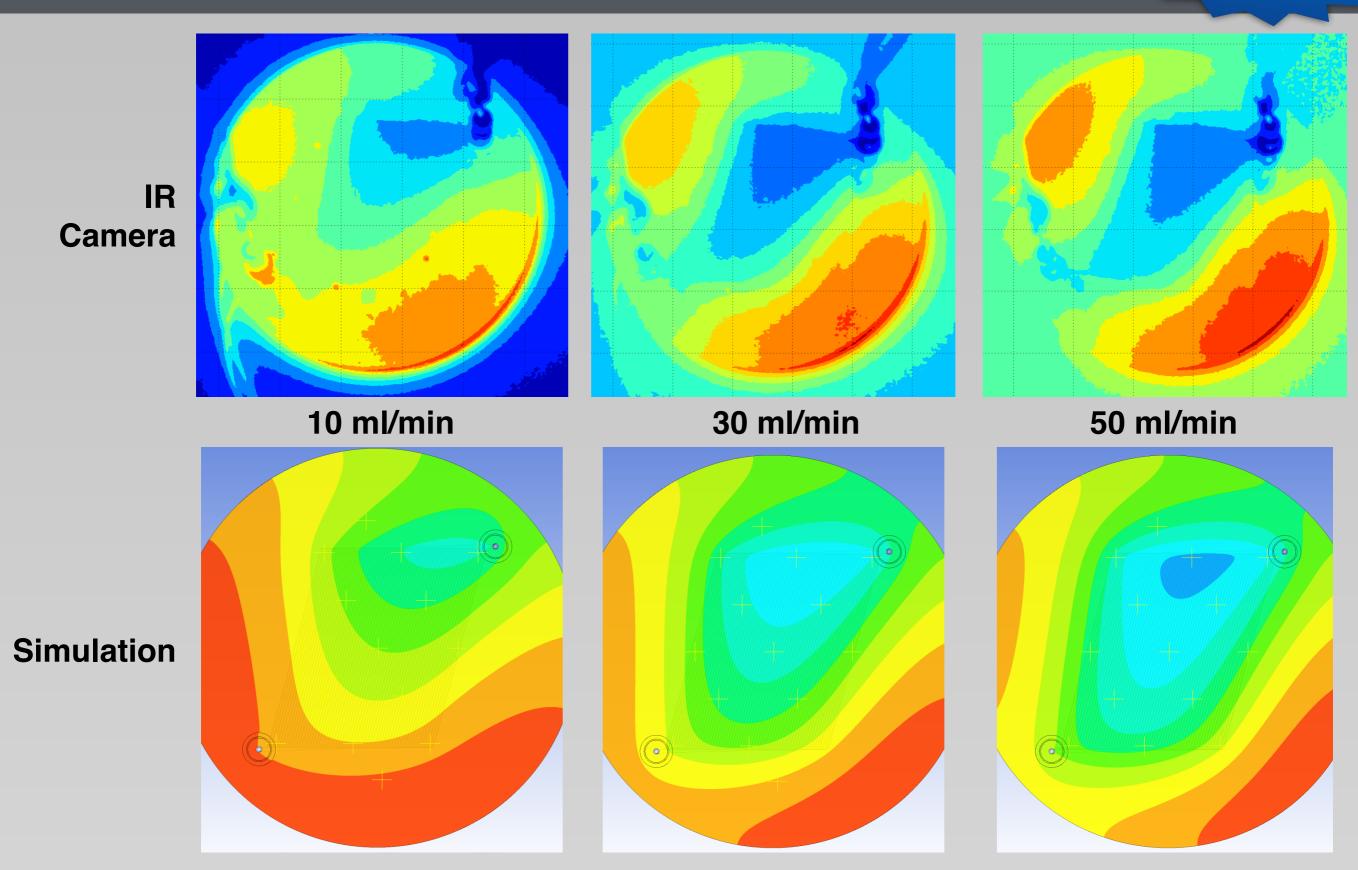


ATLAS



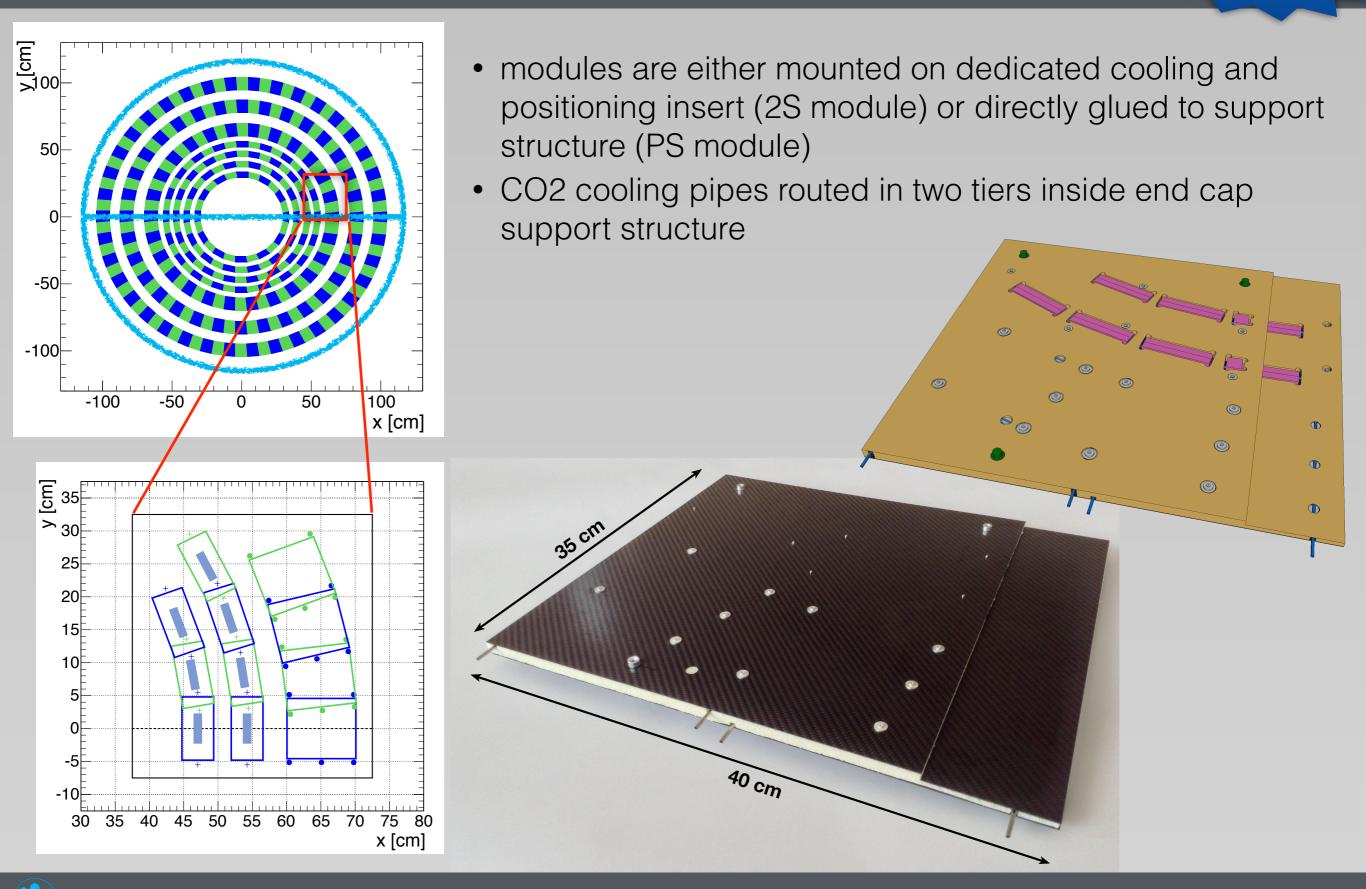
Microchannel Cooling

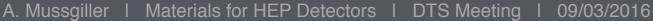




CMS TEDD Prototype

CMS





CMS TEDD Prototype

35 cm

- assembly precision is within specifications
- some drawbacks in the assembly procedure and tooling were discovered
 - will be solved for the second prototype

thickness: **10.51 mm** (expected 10.3 mm) parallelism (front / back): **95 μm** flatness: 62 μm

CMS

reason for low precision is understood. Solution is currently under development

PS Positioning Pins (6 measurements) average distance to nominal position: 29.2 μm standard deviation: 14.3 μm

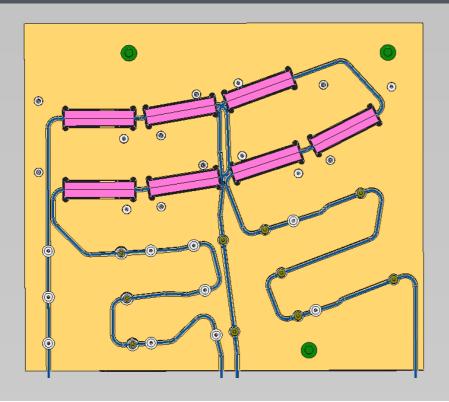
2S Cooling Inserts (10 measurements) average distance to nominal position: 22.1 μ m standard deviation: 23.8 μ m

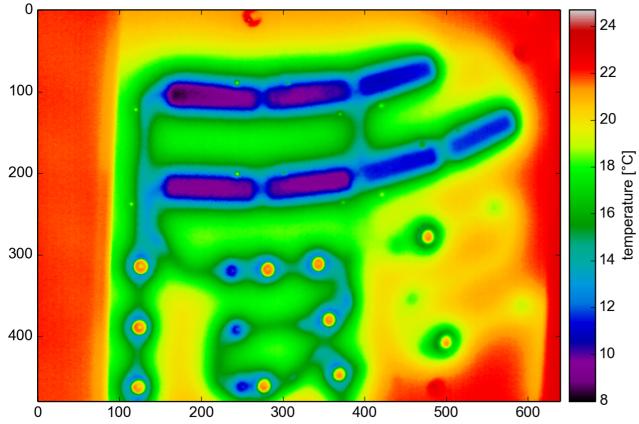
• second prototype will also include recent changes to the official design

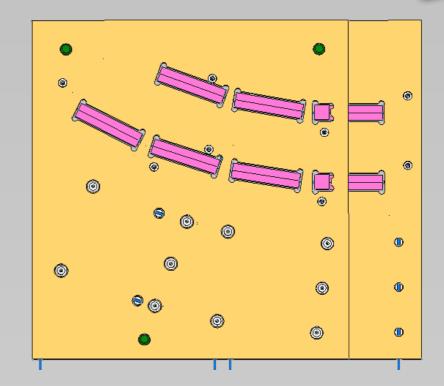
40 cm

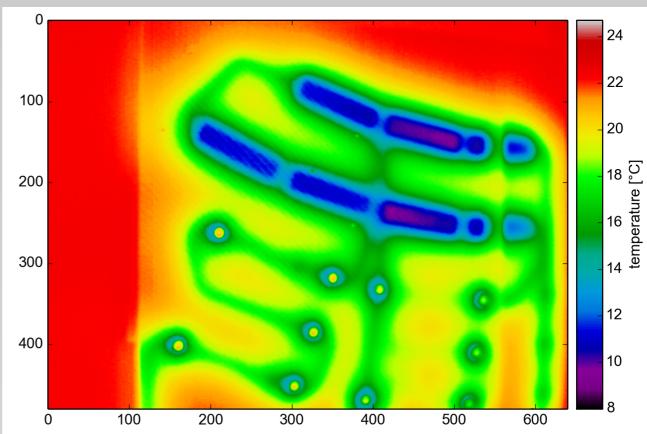
CMS TEDD Prototype







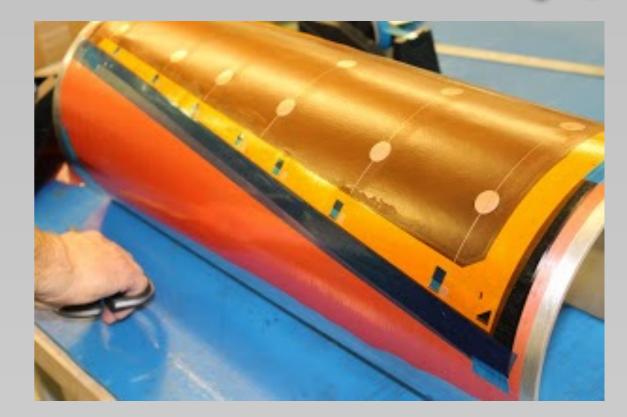


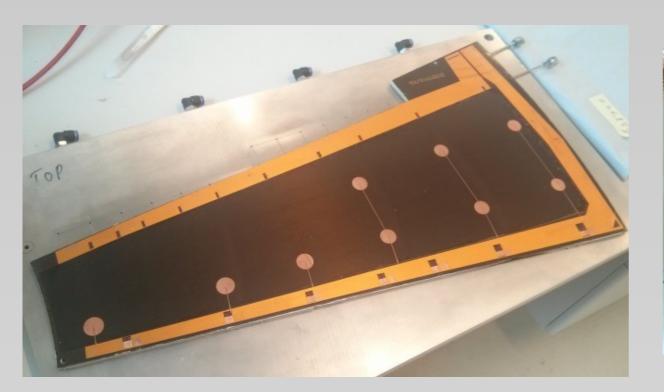


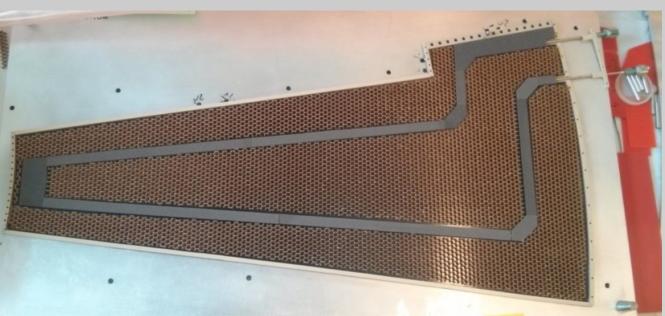
ATLAS End Cap Petals

ATLAS

- Stiff, light-weight composite carbon fibre-based structures to host the silicon microstrip modules, directly glued on core surface
- Integrated cooling pipes in the internal structure surrounded by high thermally conductive foam
- Multi-layered Kapton-Cu tape with power rails and differential data lines co-cured together with carbon fibre skins

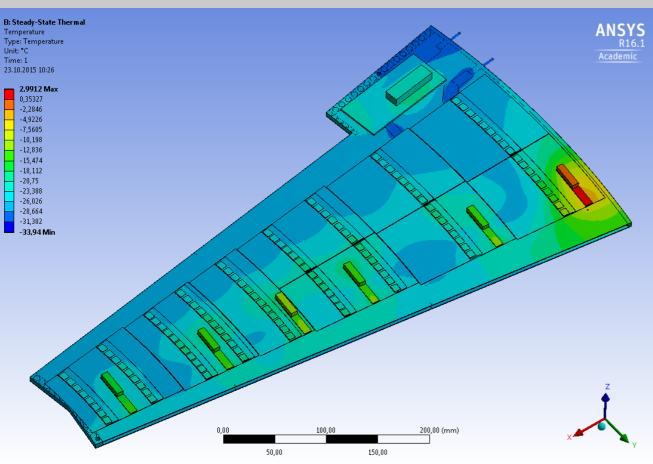


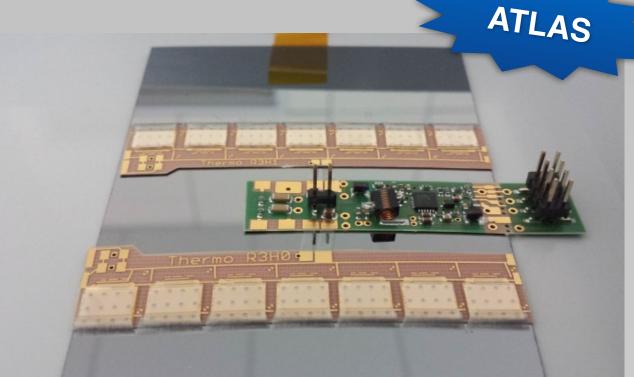


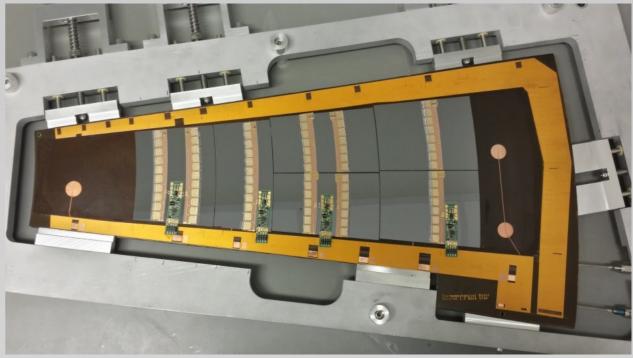


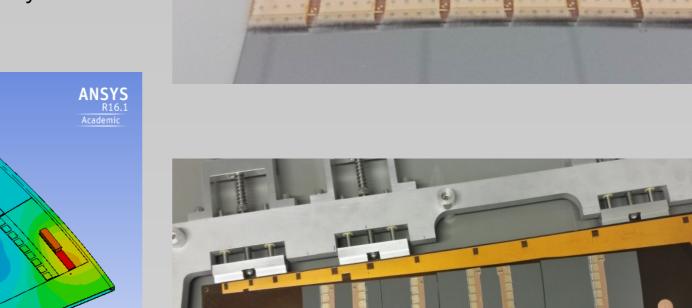
ATLAS End Cap Thermo-Mechanical Petal

- real petal core structure
- dummy silicon wavers with the real geometry
- FR4 hybrids and glass heaters to simulate front-end power
- real power boards, based on commercial DC-DC converters on a custom board
 - very first approximation to custom DC-DC converters
- module-on-core mounting tools currently in development





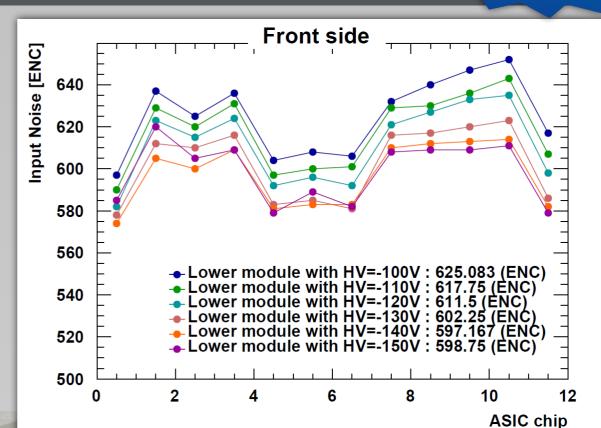


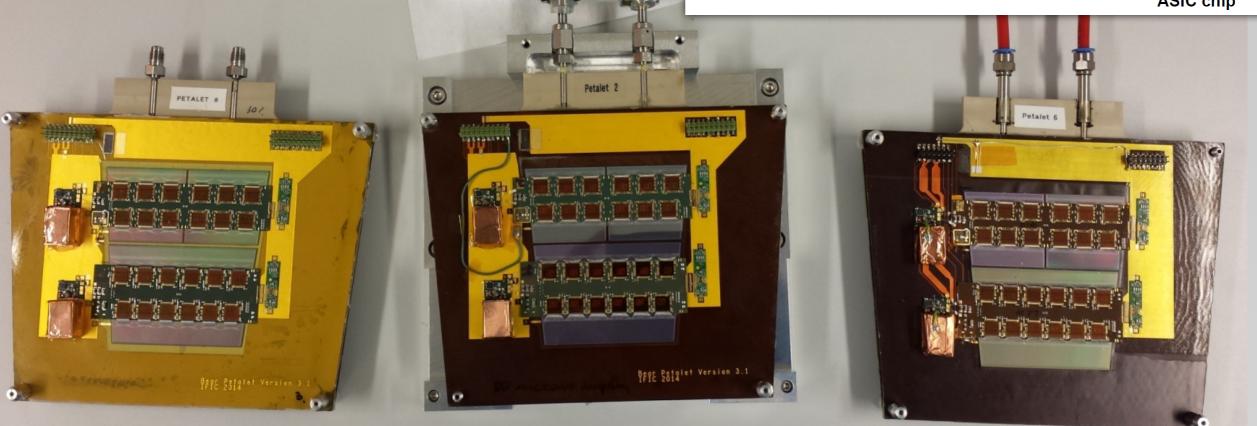


ATLAS Petalet

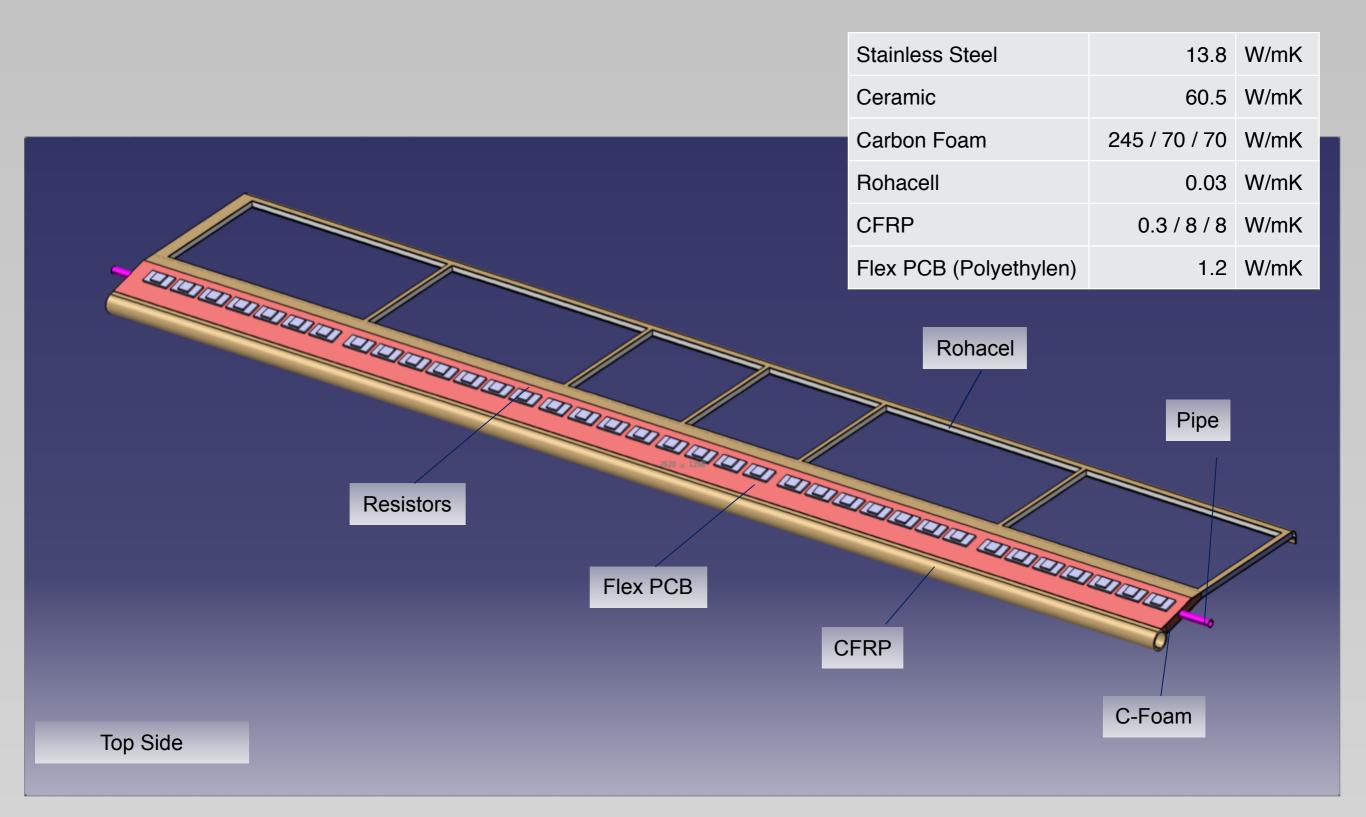
ATLAS

- Petalet program was meant to build smaller, electrically functional versions of petals to validate numerous aspects of the petal design
- one double-sided and two single-sided petalets were built and thoroughly tested at DESY



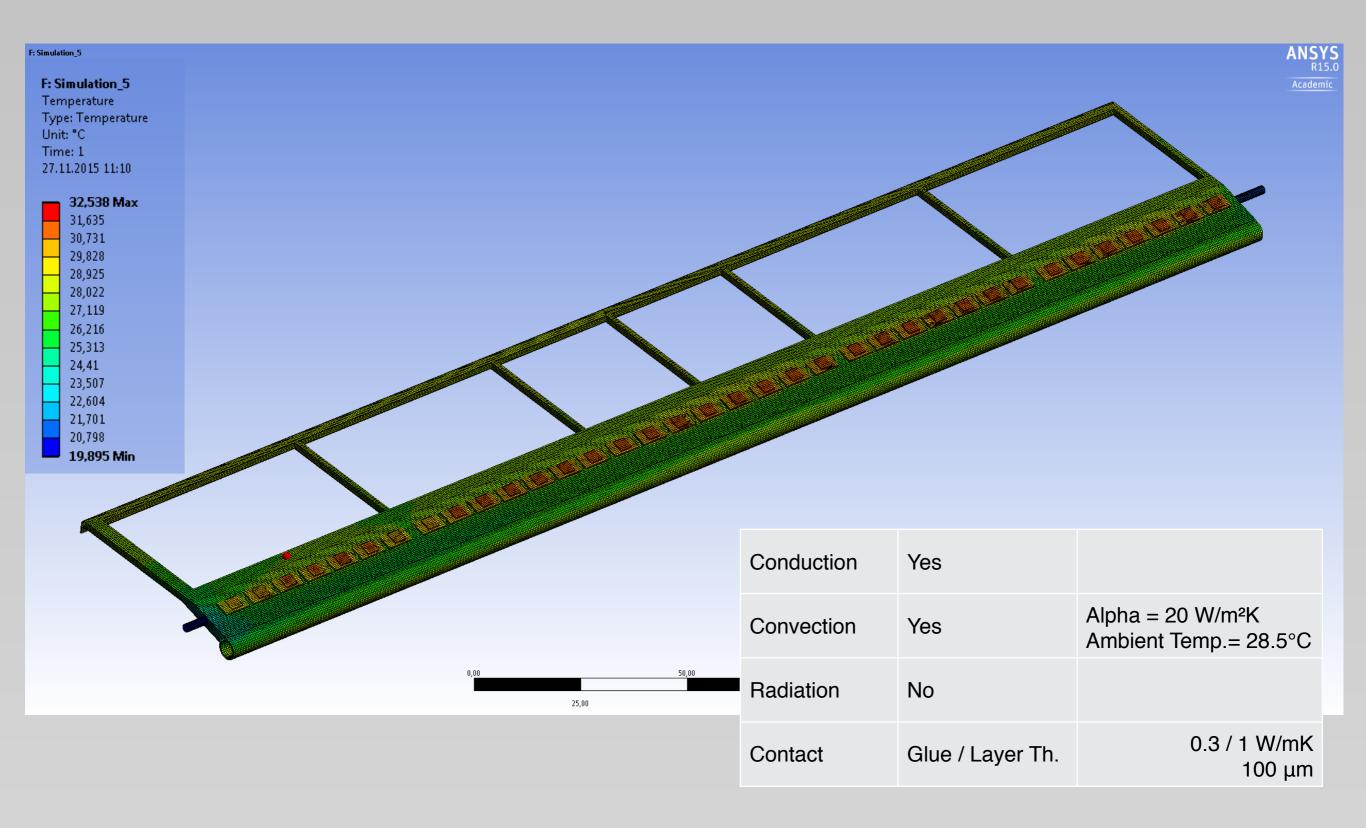


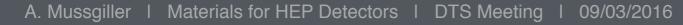
PANDA MVD Prototype Stave



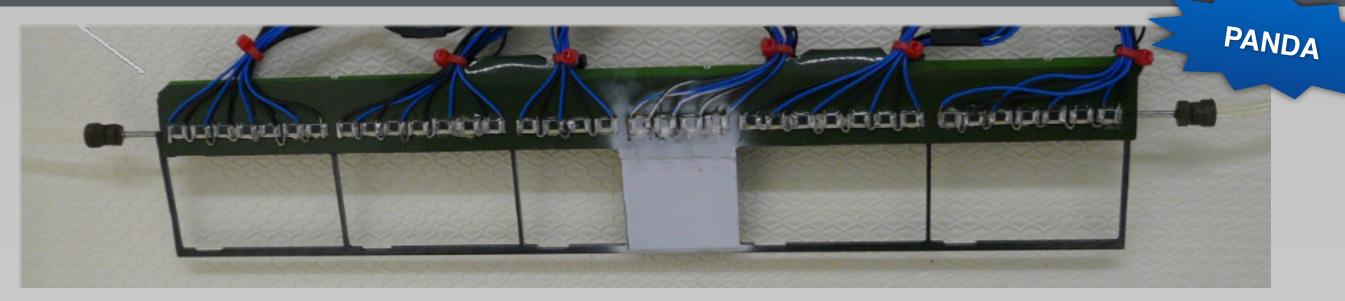
PANDA MVD Prototype Stave FEA



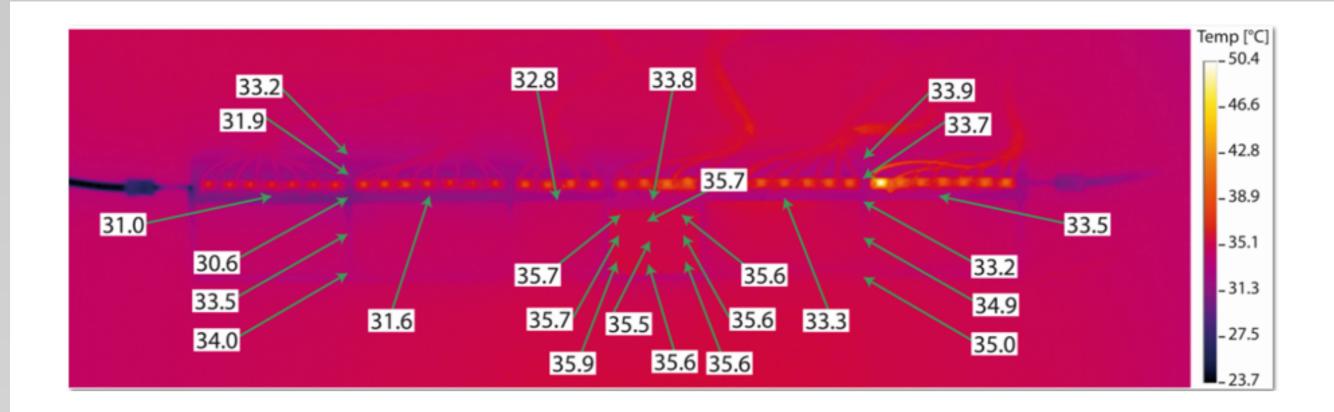




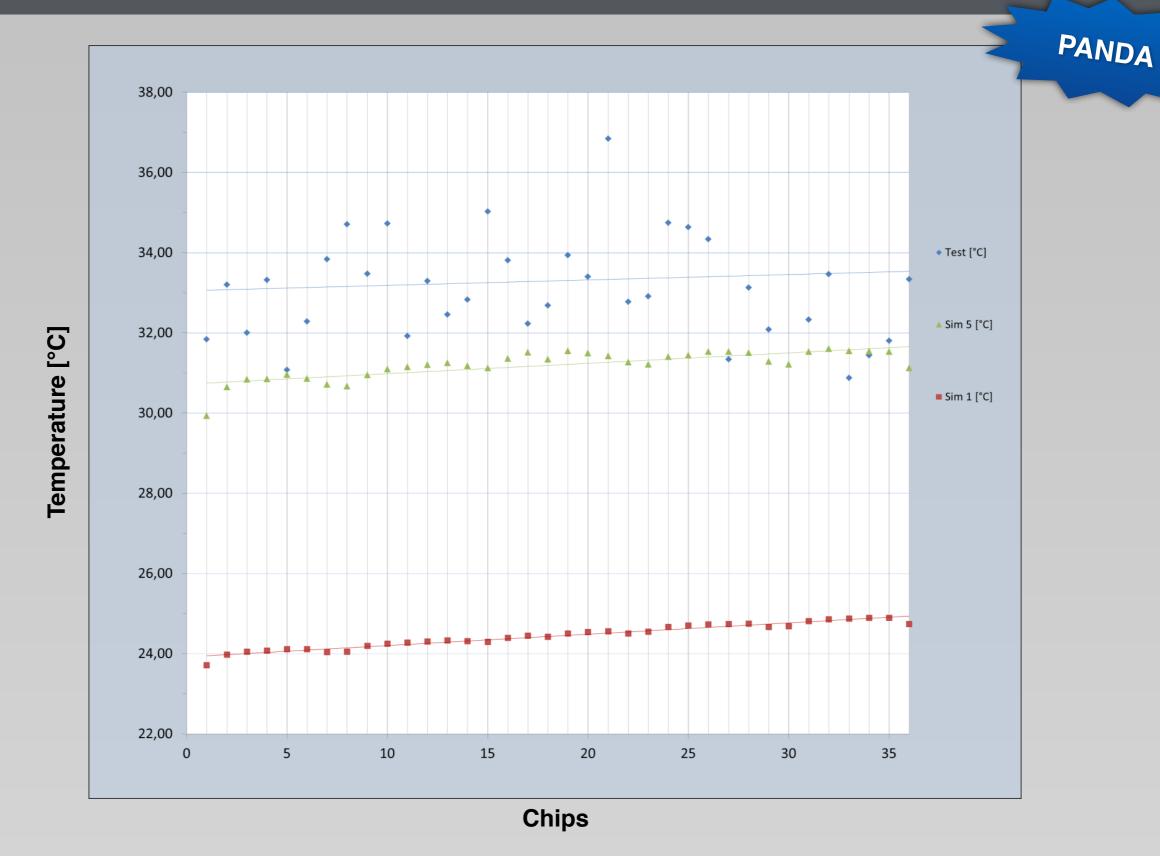
PANDA MVD Prototype Stave Measurements



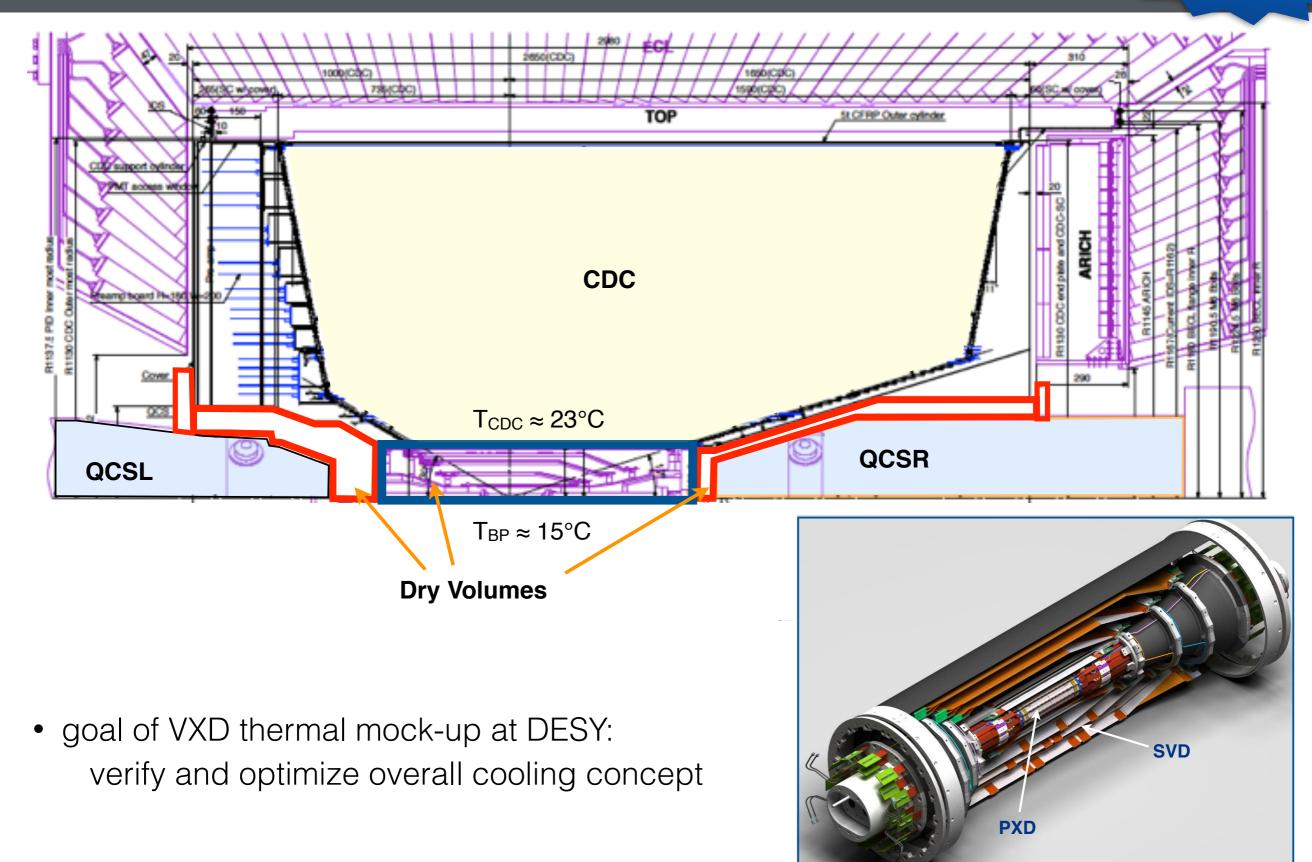
Experimental validation of simulation data



PANDA MVD Prototype Stave Measurements



Belle II VXD Cooling Environment

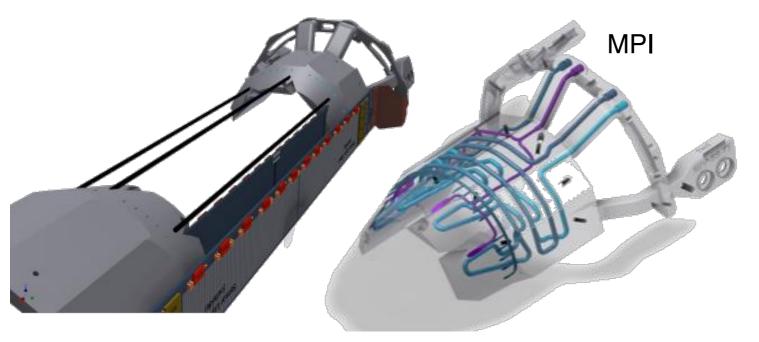


BELLE II

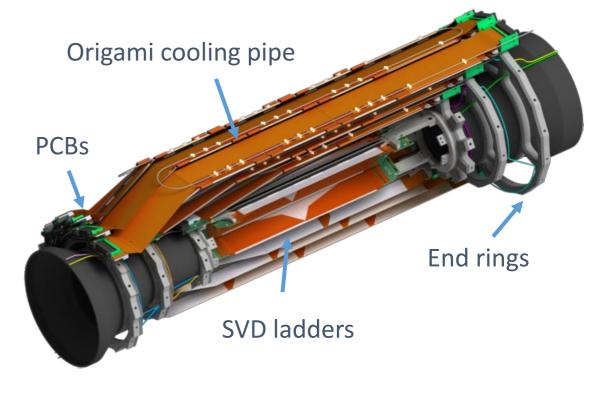
Heterogeneous VXD Cooling System

Cooling of the PXD

Cooling of the SVD



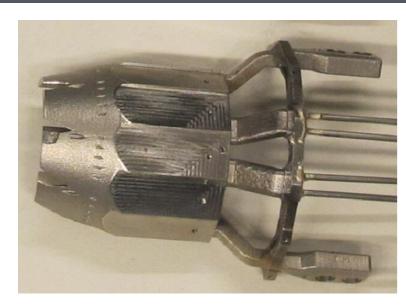
Support and Cooling Block (SCB) manufactured using 3D printing technology with integrated CO_2 and N_2 channels

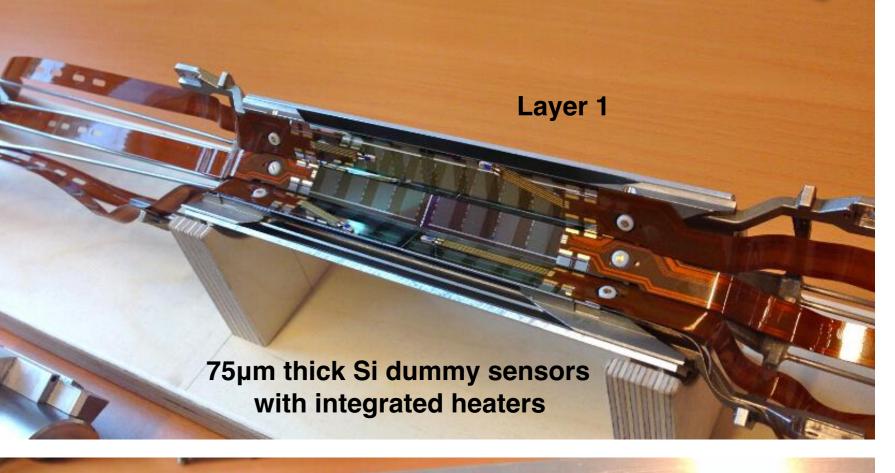


Requirements

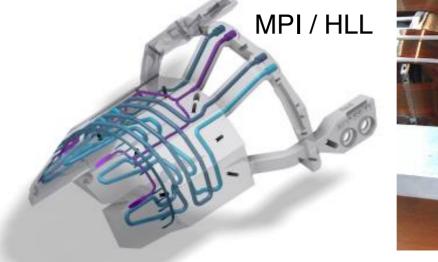
- PXD: Sensor < 25°C to minimize shot noise due to leakage current; ASICs < 50°C to avoid risk of electro-migration;</p>
- SVD: APV25 readout chips surface@~0°C for SNR improvement;
- □ Power consumption: PXD 360W; SVD 700W, required cooling capacity of 2-3kW.

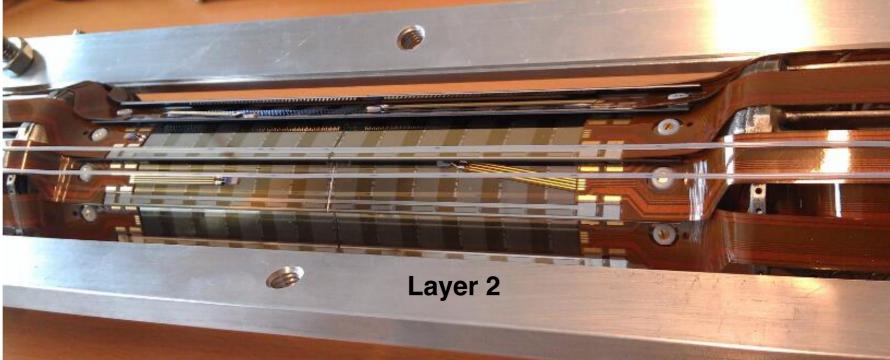
Assembly of PXD Thermal Mock-up







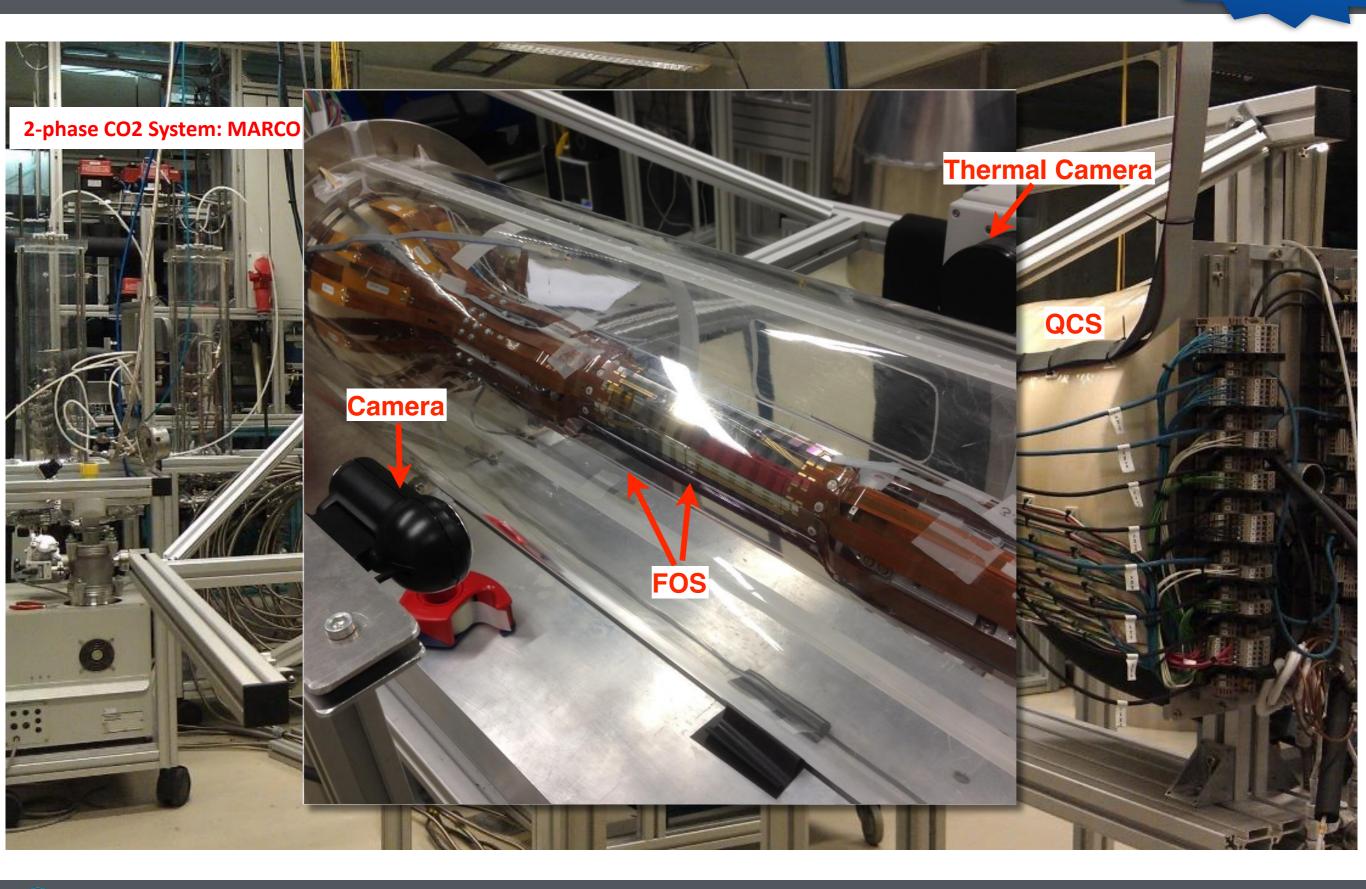




BELLE II

Status of Thermal Mock-up

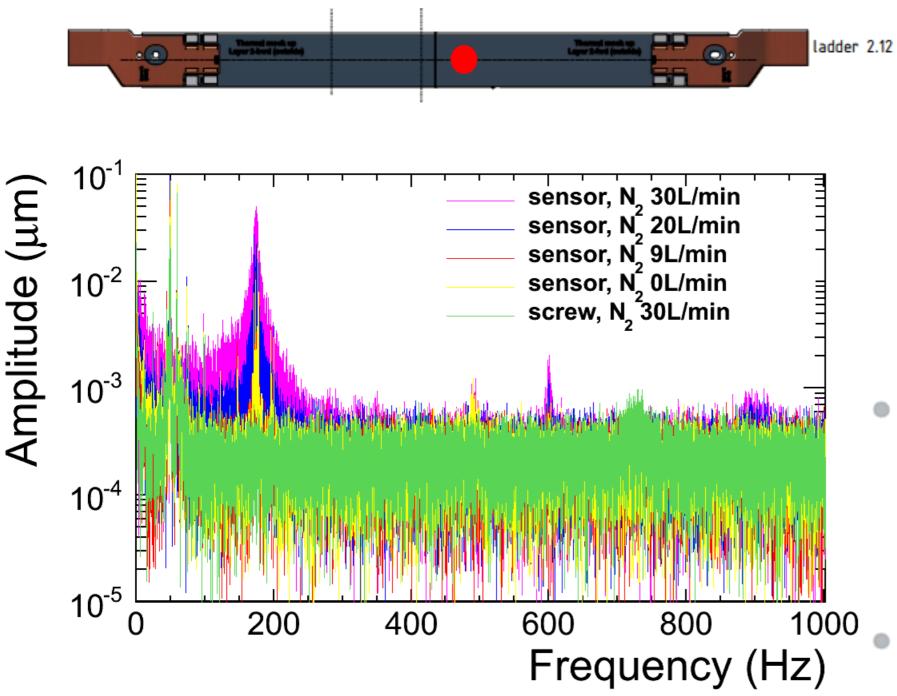


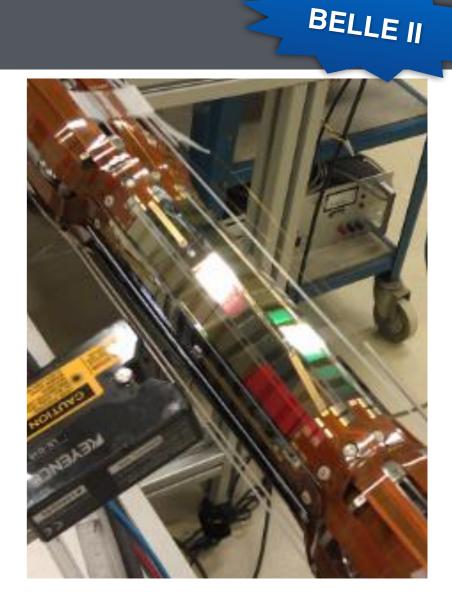


PXD Vibration Studies

Using non-contact

capacitive (sensitivity of 0.05um, band width of 5kHz) laser (sensitivity of 0.02um, band width of < 50kHz) displacement sensors.





- Measure amplitude and frequency spectrum vs N₂ flow
 - frequency peak at 175 Hz
 - amplitude < 0.04 μ m at a flow rate of 20-30 L/min
 - Not a concern for PXD operation

Forum on Tracking Detector Mechanics 2016

A meeting to discuss issues of engineering and integration for present and future tracking systems

- 23 25 May 2016
- University of Bonn
- http://indico.cern.ch/event/469996
- Abstract submission deadline: 11 March 2016

• Topics

- Detector cooling
- Deflection, stability and precision of the structures
- Thermal expansion differences inside the detector
- Mass and therefore radiation length of mechanics, cables and pipes ٠
- Humidity control ٠
- Structural issues concerning humidity or outgassing •
- Choices of construction materials ٠
- Alignment systems, requirements and "weak modes" of the system
- Pipe materials, pipe connection techniques and fittings
- Shock and vibration issues
- Effects on mechanics during fast discharge of magnet coils
- Tracker to beam-pipe interfaces •
- Radiation and mechanics: impacts on design, materials and access ٠ constraints
- Maintenance scenarios and the required special tooling
- FEA and its comparison to real objects

Forum on Tracking Detector **Mechanics 2016**

23-25 May 2016, Bonn (Germany)

A meeting to discuss issues of engineering and integration for present and future tracking systems.

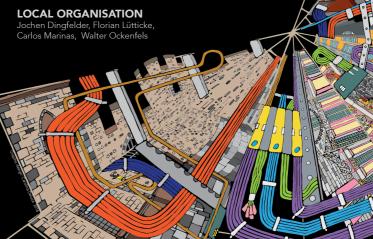
TOPICAL INTEREST

• Mechanical design • Thermal management • Quality control

SI LAB

- System integration
- FEA Simulations Lessons learned

olo Petagna, Hans Postema, Burkhard



https://indico.cern.ch/event/469996



